

Notice of References Cited	Application/Control No. 10/806,269	Applicant(s)/Patent Under Reexamination SIPPOLA, MIKA	
	Examiner Marcos D. Pizarro-Crespo	Art Unit 2814	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0030975	03-2002	Moon, Ow Chee	361/749
	B	US-			
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FOREIGN PATENT DOCUMENTS

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